19/765887 1/29/04

WE CLAIM:

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A film bulk acoustic resonator comprising:

a support;

a resonator assembly provided on the support, the assembly including a lower electrode, an upper electrode and a piezoelectric member disposed between the upper and the lower electrodes;

a first space located between the lower electrode and the support; and

a second space communicating with the first space, the second space being larger than the

10 first space.

A film bulk acoustic resonator comprising:

a substrate;

a base layer formed on the substrate;

a resonator assembly including a first electrode, a second electrode and a piezoelectric layer disposed between the first and the second electrodes, the first electrode being held in contact with the base layer; and

a space in the base layer under the resonator assembly; wherein the first electrode includes a recess facing the space. U.S. Patent Application Serial No. 10/765,887 Amendment filed March 2, 2005 Reply to OA dated December 2, 2004

AMENDMENTS TO THE CLAIMS:

This listing of claims will replace all prior versions, and listings, of claims in the application:

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Listing of Claims:

Claim 17 (currently amended): A film bulk acoustic resonator comprising:

- a support substrate made of a first material;
- a base layer formed on the substrate and made of a second material which differs from the
- 4 <u>first material:</u>
 - a resonator assembly provided on the support base layer, the assembly including a lower electrode, an upper electrode and a piezoelectric member disposed between the upper and the lower electrodes;
 - a first space <u>portion</u> located <u>formed only in the base layer</u> between the lower electrode and the support; and
 - a second space <u>portion</u> communicating <u>formed only in the base layer in communication</u> with the first space <u>portion</u>, the second space <u>portion</u> being larger than the first space <u>portion</u>.
 - Claim 18 (original): A film bulk acoustic resonator comprising:
- ¹ 2 a substrate;
 - a base layer formed on the substrate;
 - a resonator assembly including a first electrode, a second electrode and a piezoelectric layer

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- disposed between the first and the second electrodes, the first electrode being held in contact with
- 6 the base layer; and
- a space in the base layer under the resonator assembly;
- wherein the first electrode includes a recess facing the space.